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PATENT
Docket No. 150.00810102IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Brian A. Vaartstra

Patent No.: 6,786,936 B2

Issued: September 7, 2004

For: METHODS, COMPLEXES, AND SYSTEMS FOR FORMING METAL-
CONTAINING FILMS ON SEMICONDUCTOR STRUCTURESREQUEST FOR CERTIFICATE OF CORRECTION

Attention Certificate of Correction Branch
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Certificate
FEB 25 2005
of Correction

Sir:

A Certificate of Correction is requested to be issued correcting printing errors appearing in the above-identified United States patent. Two copies of the text noting the corrections for the Certificate are enclosed. Since none of the errors listed are due to Applicant's mistake, no fee is necessary for the Certificate. The corrections in the proposed Certificate of Correction do not involve such changes in the patent as would constitute new matter or would require reexamination.

Please mail the printed Certificate of Correction to the undersigned attorney.

CERTIFICATE UNDER 37 C.F.R. 1.8:

The undersigned hereby certifies that this paper is being deposited in the United States Postal Service, as first class mail, in an envelope addressed to: Attention Certificate of Corrections Branch, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 16 day of February, 2005.

Loren D. Albin

Respectfully submitted for
Brian A. Vaartstra

By
Muetting, Raasch & Gebhardt, P.A.
P.O. Box 581415
Minneapolis, MN 55458-1415
Phone: (612)305-1220
Facsimile: (612)305-1228
Customer Number 26813

Date

February 16, 2005

By: Loren D. Albin
Reg. No. 37,763
Direct Dial (612)305-1225

MAR 02 2005

UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO.: 6,786,936 *B2*

DATED: September 7, 2004

INVENTOR(S): Brian A. Vaartstra

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

In column 4, line 32, please delete "nitrites" and insert --nitriles--;

In column 5, line 8, please delete "suicides" and insert --silicides--;

In column 7, line 61, please delete "siticide" and insert --silicide--;

In column 10, line 29, please delete "(Chemicals" and insert --Chemicals--;

In column 11, line 6, please delete "CNR³, R⁸CN," and insert --CNR⁵, R⁶CN--.

MAILING ADDRESS OF SENDER:

PATENT NO. 6,786,936

MUETING, RAASCH & GEBHARDT, P.A.
P.O. BOX 581415
MINNEAPOLIS, MINNESOTA 55401
Customer Number 26813

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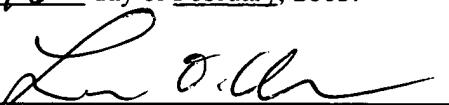
We are transmitting the following documents along with this Transmittal Sheet (which is submitted in triplicate):

- An itemized return postcard.
 Request for Certificate of Correction (1 pg.);
 Certificate of Correction (1 pg. - in duplicate)

Please consider this a PETITION FOR EXTENSION OF TIME for a sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 13-4895. Triplicate copies of this sheet are enclosed.

CERTIFICATE UNDER 37 C.F.R. §1.8: The undersigned hereby certifies that this Transmittal Letter and the paper(s), as described hereinabove, are being deposited in the United States Postal Service, as first class mail, in an envelope addressed to: Attention Certificate of Correction Branch, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 16 day of February, 2005.

MUETING, RAASCH & GEBHARDT, P.A.
Customer Number: 26813

By: 
Loren D. Albin
Reg. No.: 37,763
Direct Dial: 612-305-1225
Facsimile: 612-305-1228

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